EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	1	(gas and (chuck support holder susceptor) and bleed$3 and orifice and evacuat$3).clm.	US-PGPUB; USPAT	OR	ON	2006/08/09 09:28
L2	0	((wafer substrate) and (thermal$3 temperature) and control$4 and bleed$3 and orifice and evacuat$3).clm.	US-PGPUB; USPAT	OR	ON	2006/08/09 09:28

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